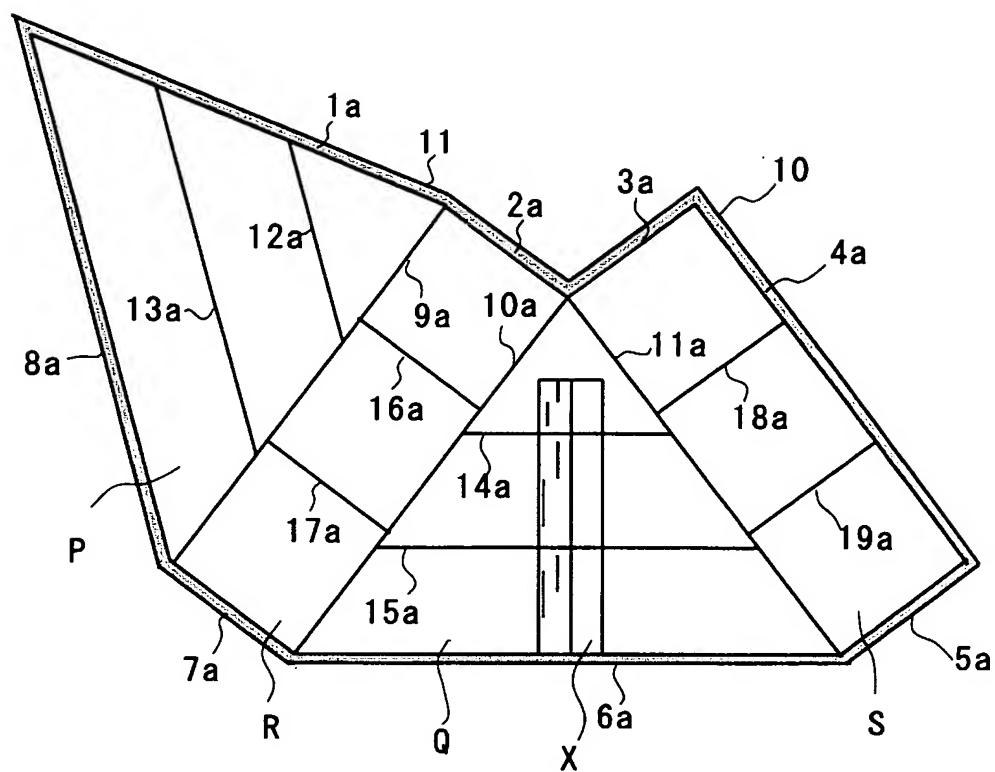


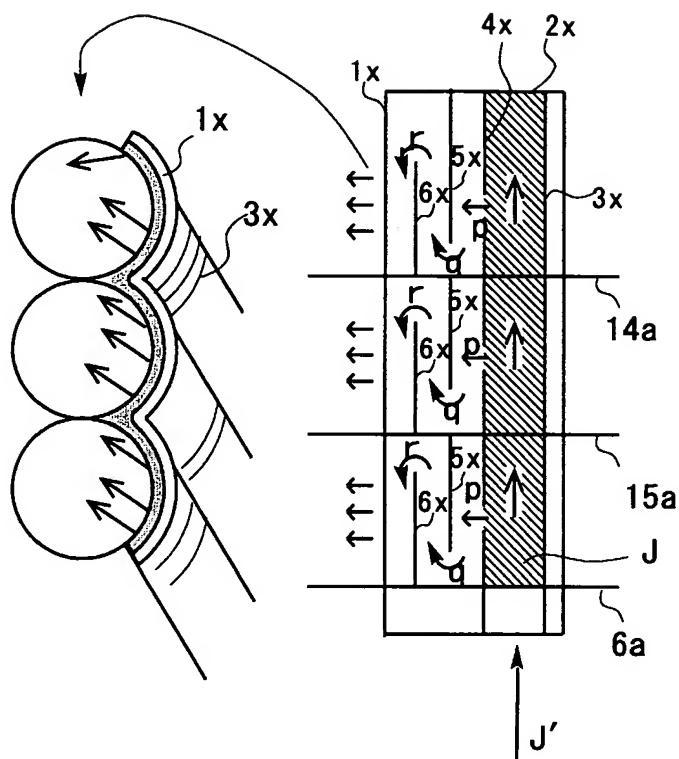
[図1]

Fig. 1



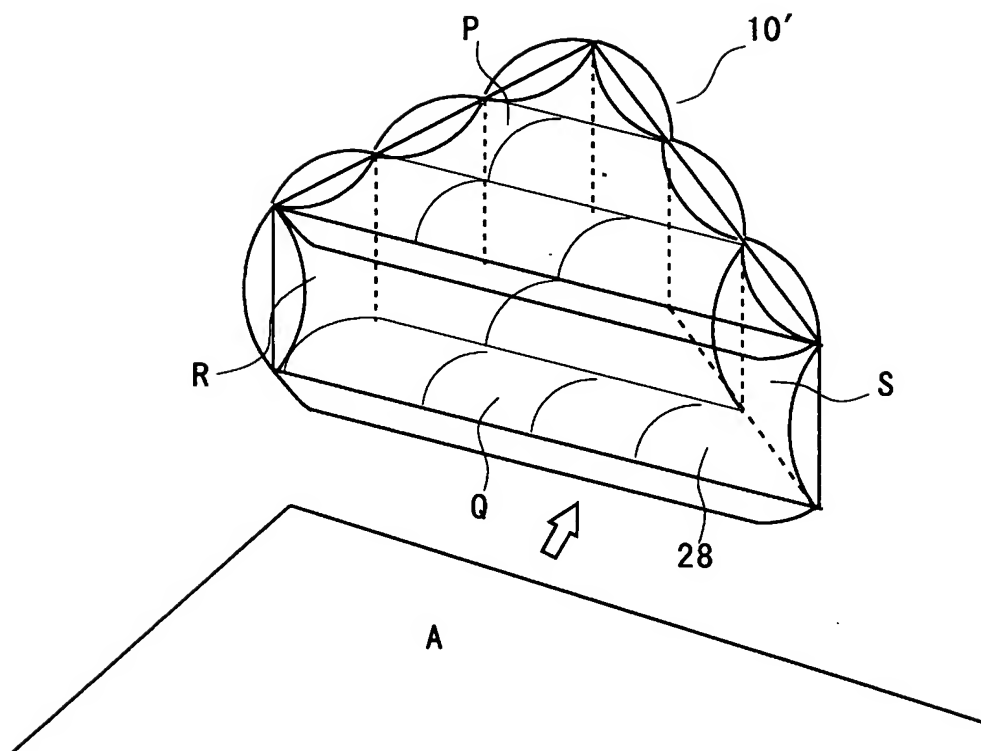
[図2]

Fig. 2



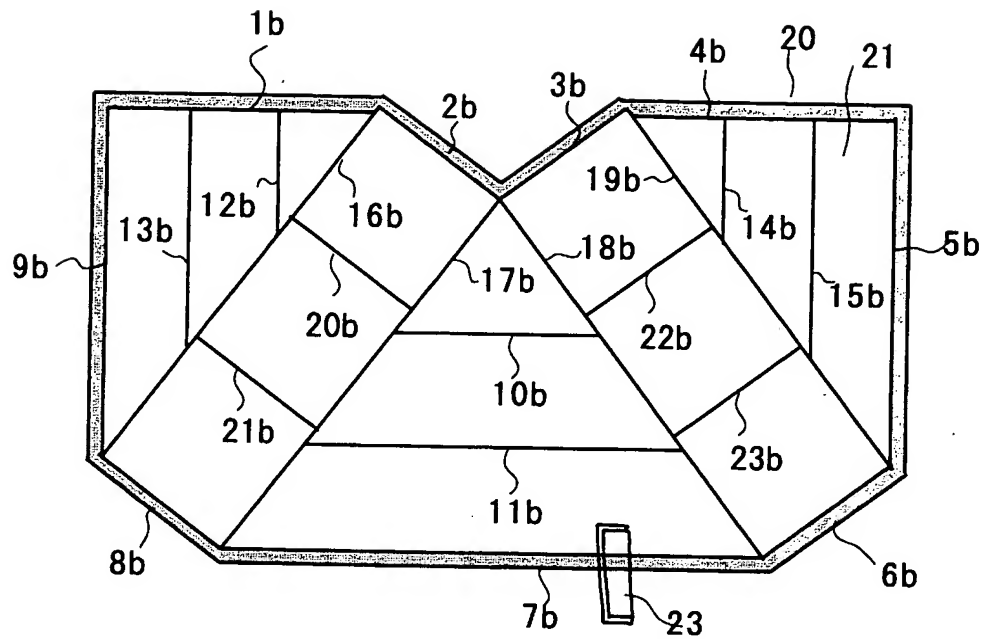
[図3]

Fig. 3



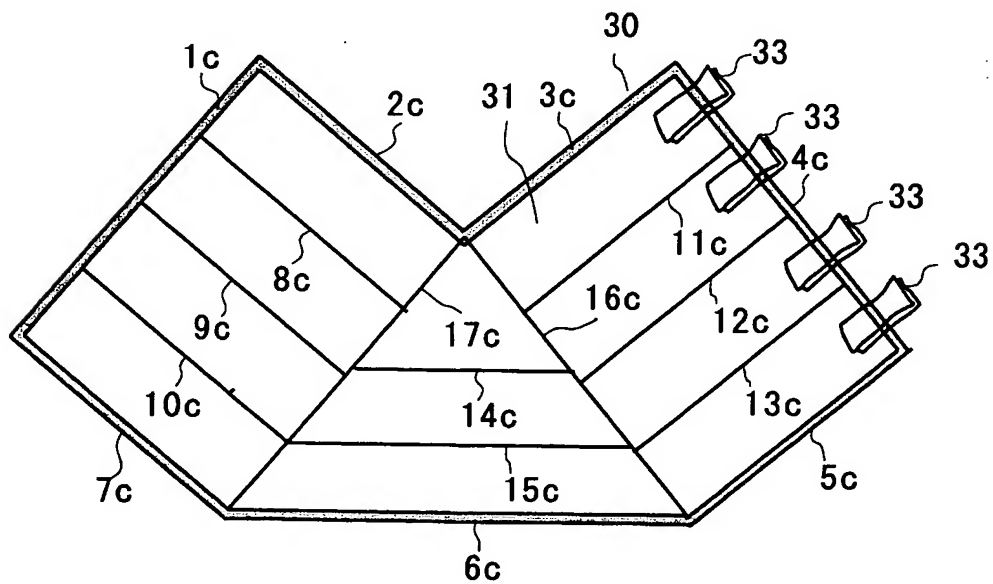
[図4]

Fig. 4



[図5]

Fig. 5



[圖6]

Fig. 6

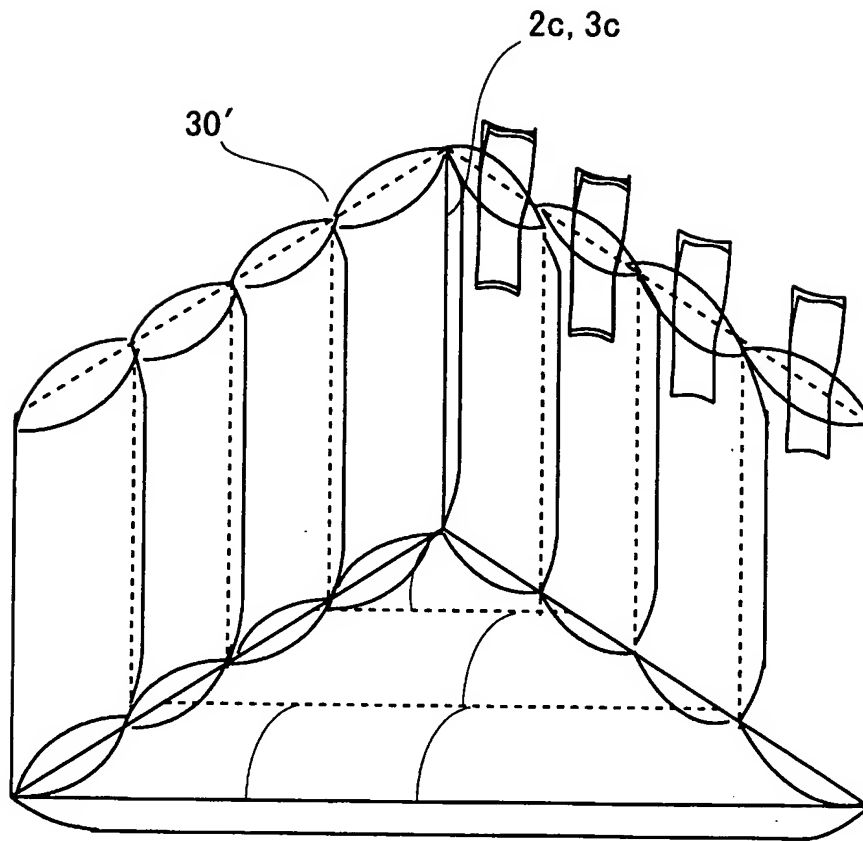
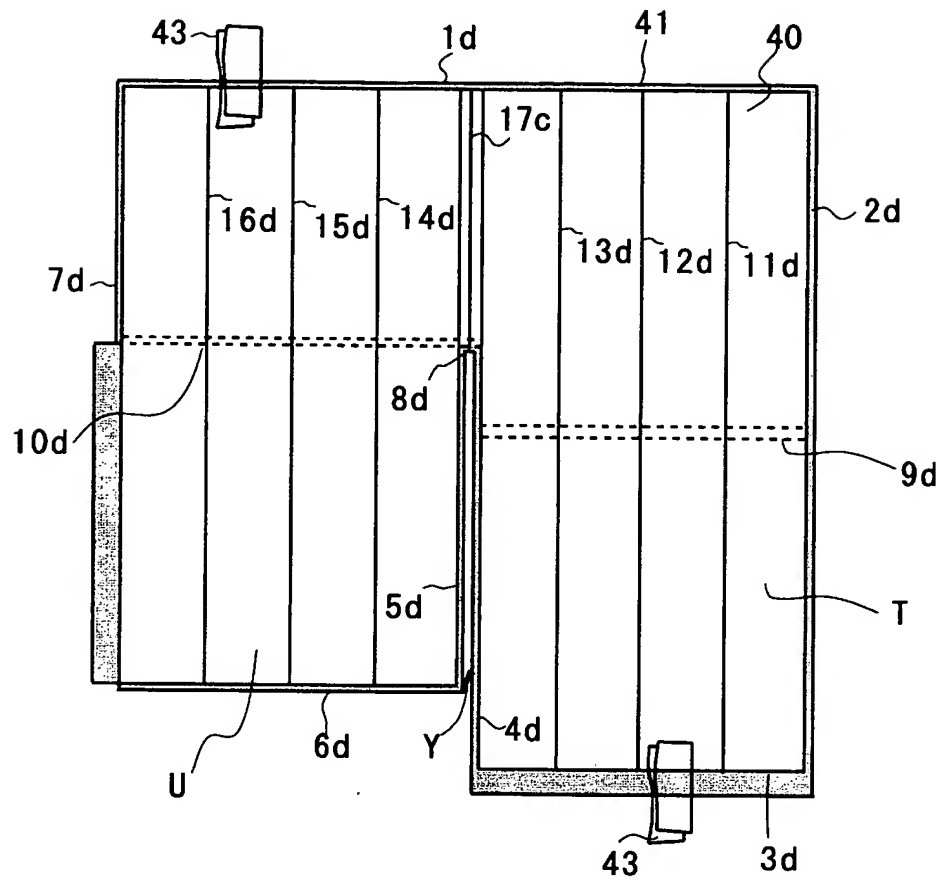
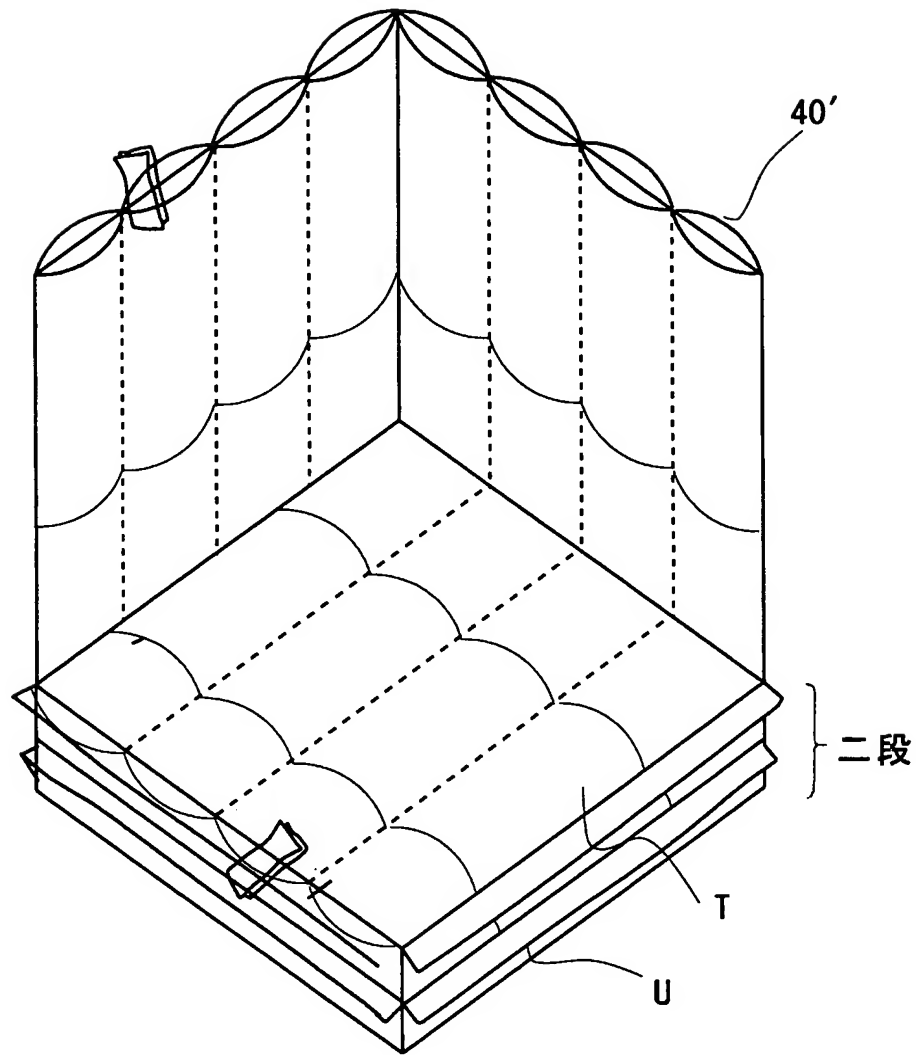


Fig. 7



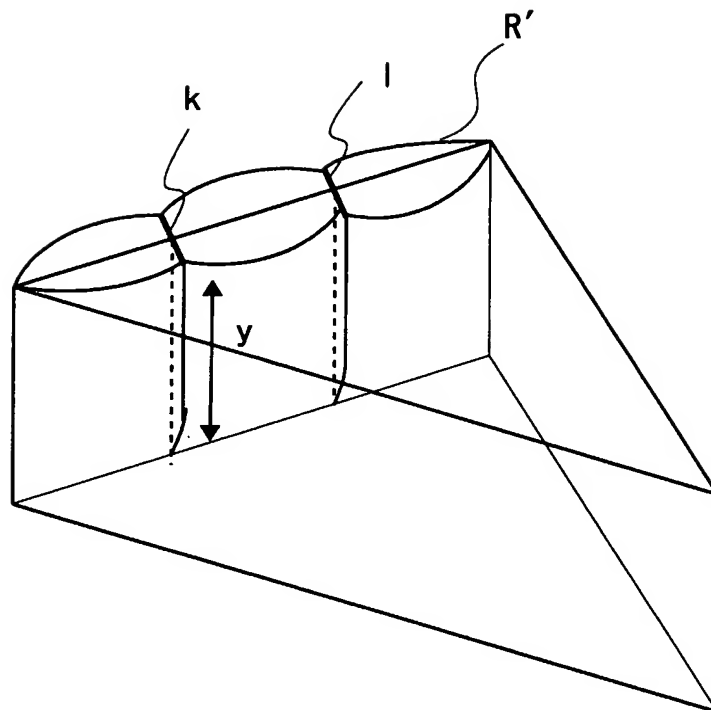
[圖8]

Fig. 8



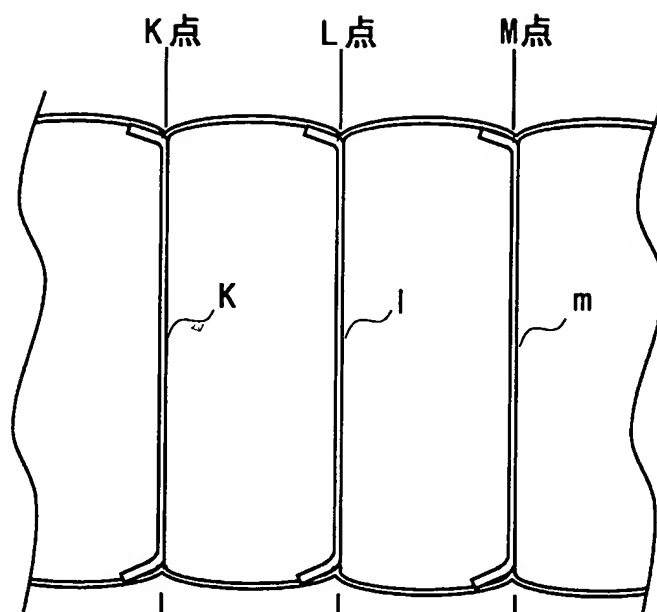
[圖9]

Fig. 9



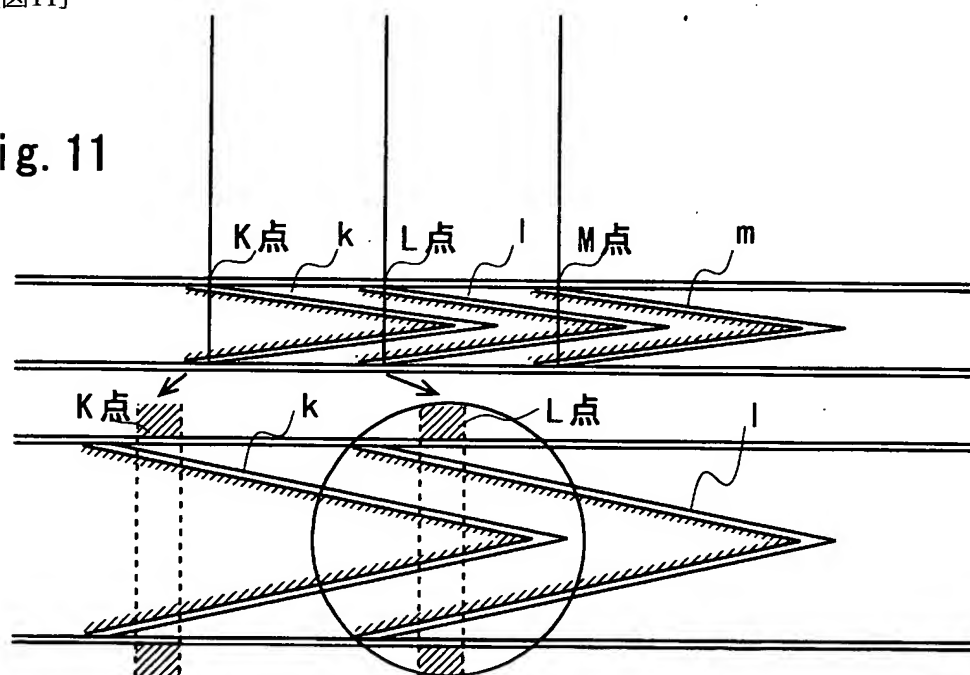
[图10]

Fig. 10



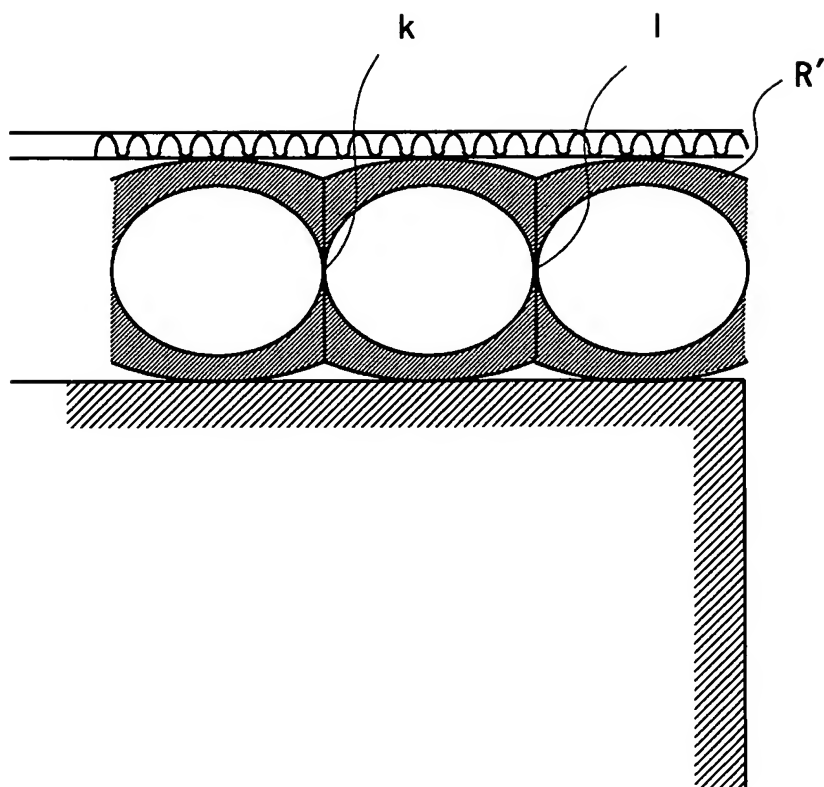
[图11]

Fig. 11



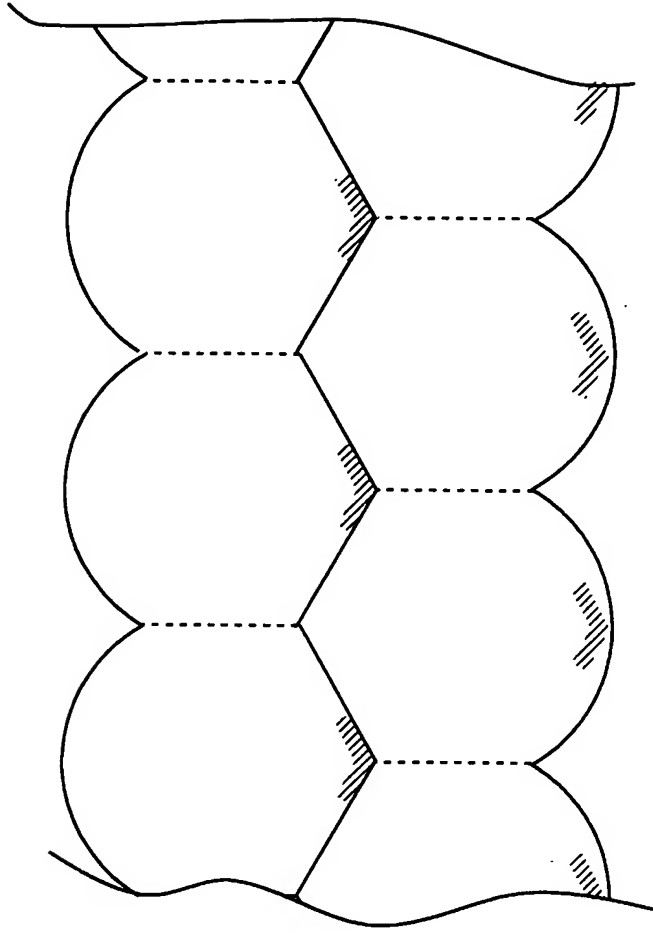
[図12]

Fig. 12



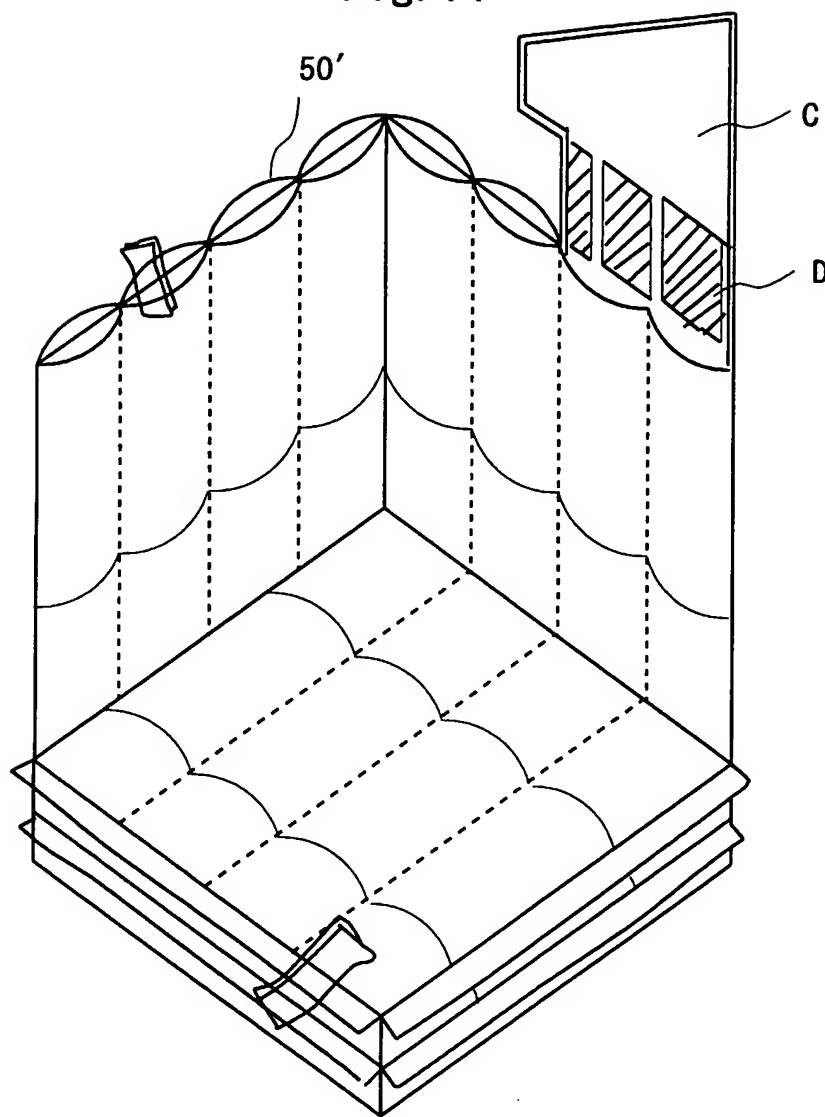
[圖13]

Fig. 13



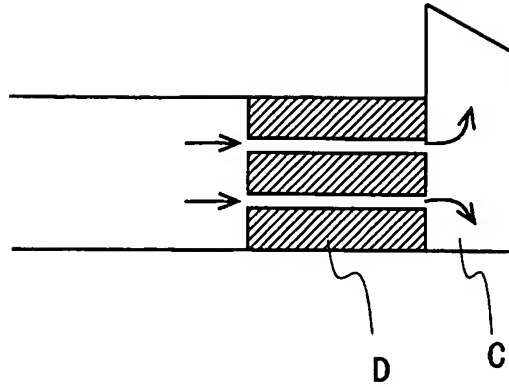
[圖14]

Fig. 14



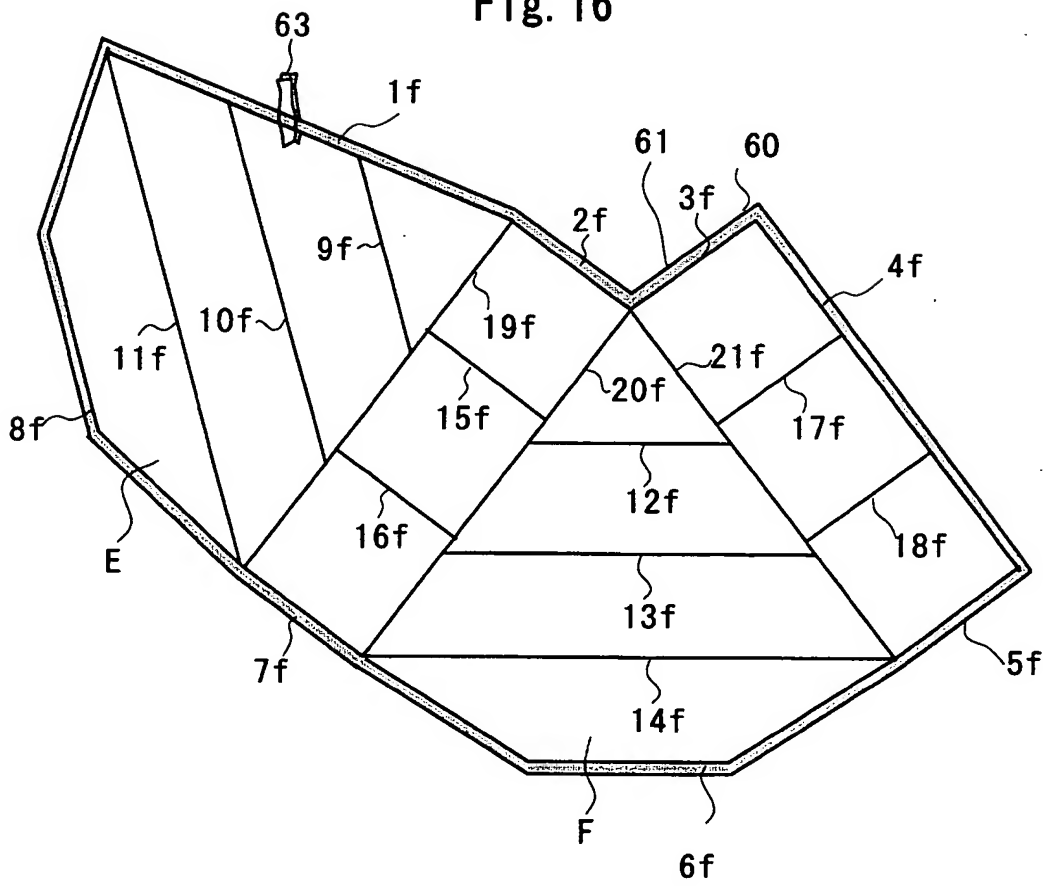
[図15]

Fig. 15



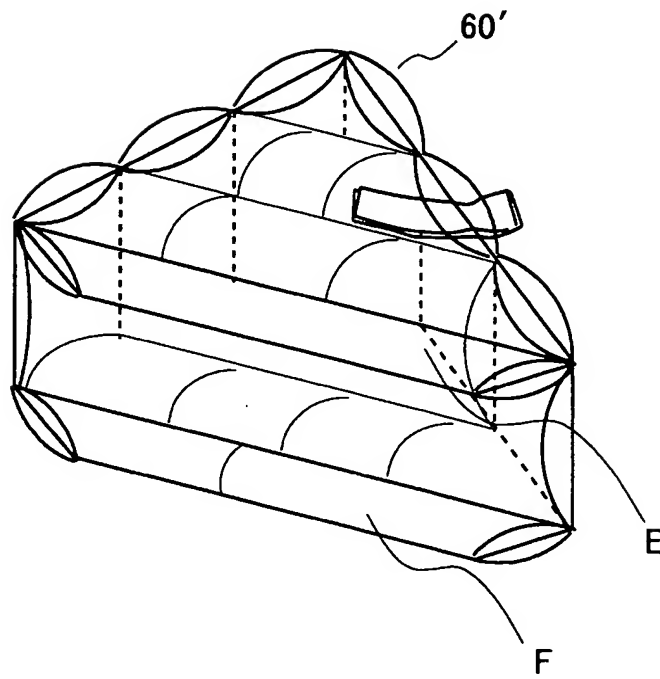
[図16]

Fig. 16



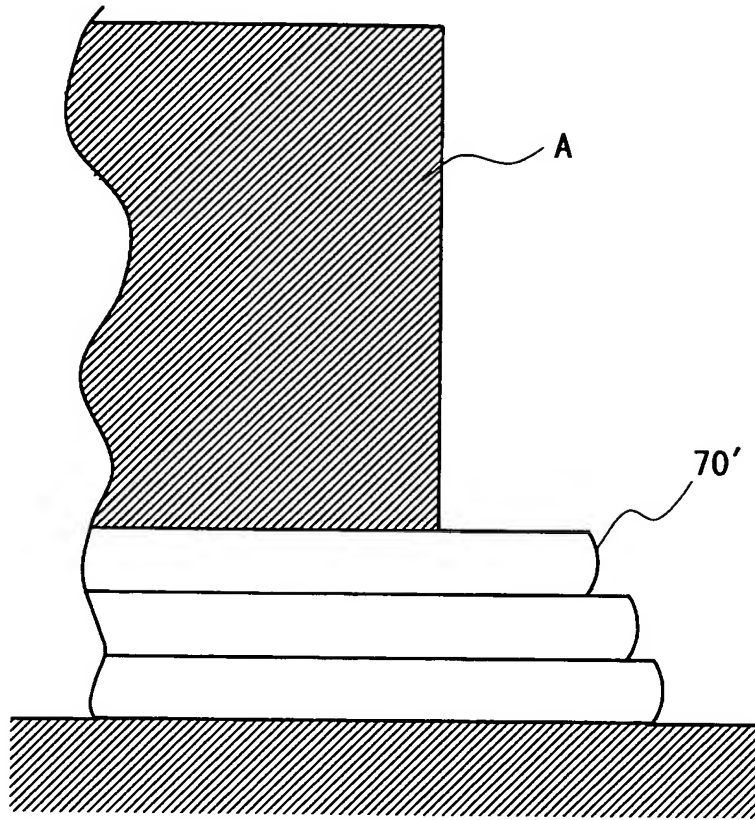
[Fig. 17]

Fig. 17



[圖18]

Fig. 18



[図19]

Fig. 19

